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Field emission beam characteristics of single metal nanotip cathodes with on-chip collimation gate electrode

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Field-emission and beam collimation characteristics of single metal nanotip devices with double-gate electrodes are studied. Applying a previously developed method to fabricate all-metal double-gate nanotip arrays with a stacked on-chip extraction G_{ext} and collimation G_{col} gate electrodes with the large G_{col} apertures, the authors produced single double-gate nanotip devices and measured their beam characteristics. Excellent beam collimation capability with minimal reduction of the emission current and the enhancements of the current density up to a factor of ~ 7 was observed. The results indicate that these single nanotip devices are highly promising for electron beam applications that require extremely high brilliance and coherence. © 2015 American Vacuum Society. [<http://dx.doi.org/10.1116/1.4913397>]

I. INTRODUCTION

Ultrabright cathodes are critical elements in a broad range of applications such as cathodes for x-ray free electron lasers as well as time resolved electron microscopy and diffraction experiments that aim at resolving the dynamics of materials and molecules on the atomic length and time scales. One of the core requirements for such cathodes is the generation of a low emittance electron beam with high current to ensure the delivery of sufficient current to the target. For such applications, metal nanotip field emitters^{1–8} are attracting considerable interest recently as high brilliance cathodes that may outperform state-of-the-art photocathodes. This is because metal nanotips allow high emission current with narrow energy spread via quantum tunnelling of electrons through the surface barrier at the nanometer scale emitter tip apexes. One can also generate ultrafast electron pulses by exciting the metal nanotips with ultrafast laser pulses.^{1–7} So far, etched-wire needle-shaped field emitters prepared by electrochemical etching and *in-situ* thermal treatment have been the most widely studied.^{1–5} However, for high charge, high beam brilliance applications, the cathode must be used under a high acceleration electric field, on the order of 10–100 MV/m, i.e., the maximum extraction field conditions for minimum space-charge broadening to conserve the beam brilliance with the highest bunch density possible. This makes the nanofabricated metal nanotip emitters with on-chip gate electrodes

attractive for many applications since the electron emission can be switched with the application of a low gate potential on the order of 100 V independently from the acceleration field.^{9,10} In fact, integration of the single-gate field emission array (FEA) into a combined diode-RF cavity electron gun and stable subnanosecond pulsed field emission operation under the acceleration field up to 30 MV/m has been reported recently.⁹

Further, highly collimated electron beams can be generated from double-gate FEAs by adding a collimation gate electrode on top of the electron extraction gate electrode and individually collimating the field emission beamlet.¹¹ We note that this is crucial to generate the high intrinsic brilliance FEA beam.^{12,13} The intrinsic transverse beam emittance of a single beamlet, given by the root-mean-square (rms) radius R_{tip} of the emitter tip apex and the angular divergence equal to $\sim 30^\circ$, is on the order of 10^{-3} mm mrad. This extremely small value is a consequence of the small R_{tip} in the nanometer range. In the case of single-gate FEAs with the large target current of several amperes, the transverse beam emittance is on the order of 1 mm mrad. However, the transverse emittance can be much reduced with double-gate FEAs. By decreasing the angular beam divergence of the individual beamlet by an order of magnitude, the double-gate FEA beam can potentially achieve an intrinsic emittance lower than that of state-of-the-art high brilliance photocathode (equal to ~ 0.2 mm mrad with the cathode radius of 0.5 mm).

The excellent beam collimation capability of double-gate FEAs with a large collimation gate aperture was

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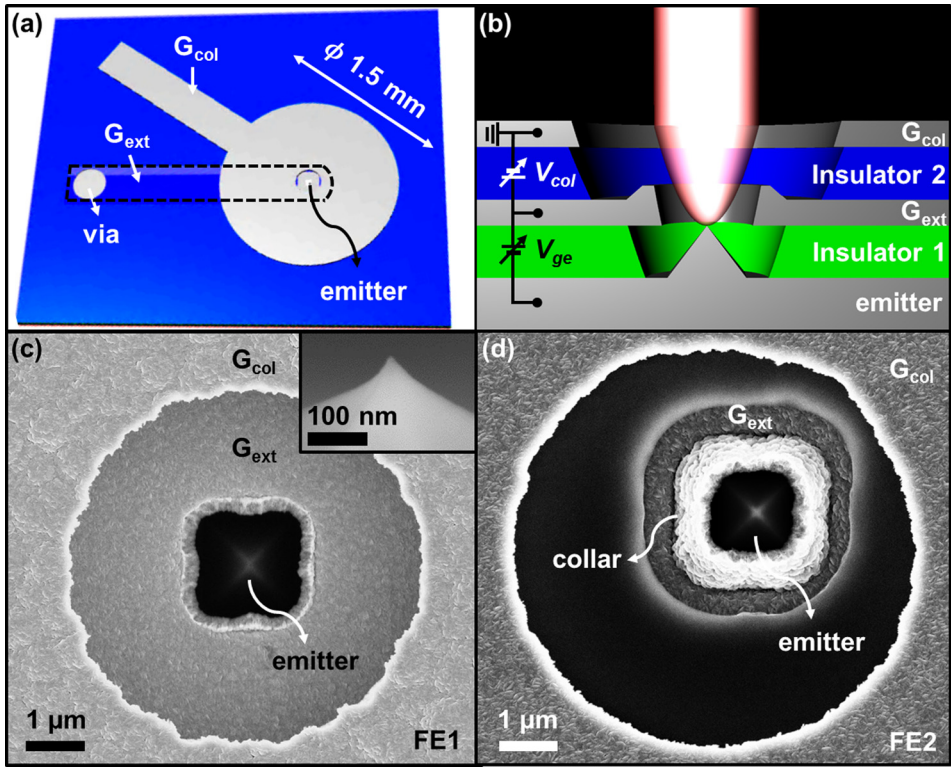


FIG. 1. (Color online) (a) Top-view and (b) cross-sectional-view schematic diagram of the double-gate single nanotip emitter device. In (a), the dotted line indicates the G_{ext} electrode buried underneath the insulator 2. The electrical contact to G_{ext} is provided through via hole through the insulator 2. The G_{col} electrode is a 1.5 mm-diameter circular shape with a rectangular contact pad. In (b), the schematic trajectory (envelope) of the maximally collimated beam with V_{col} equal to $\sim(-V_{ge})$ is shown. (c) and (d) show the SEM image of FE1 and FE2, respectively. Inset of (c) shows the high magnification SEM image of emitter tip apex of FE1 observed with the viewing angle of 47° .

experimentally demonstrated recently.¹³ An order of magnitude enhanced beam intensity was observed from a 4×10^4 tip double-gate FEA at the maximally collimated condition. Together with the compatibility with high acceleration electric field extraction and the possibility to generate ultrafast electron pulses using near infrared ultrafast laser excitation, these FEAs are highly promising as ultrabright electron sources that may open up new applications in femtosecond time resolved applications.

In this work, we study the field emission and beam collimation properties of single nanotip double-gate emitters to investigate the characteristics of the individual nanotips that were only inferred in the previous experiments on arrays. Such investigation is important on one hand to further improve the beam collimation properties and beam uniformity for scaling to arrays, and on the other hand, to explore the applicability of such metal nanotips for high brilliance beam applications.

II. SAMPLE AND EXPERIMENT

Two double-gate single nanotip devices (FE1 and FE2), see Fig. 1 and Table I, studied in this work were fabricated by adapting the fabrication method for arrays of double-gate emitters.^{14,15} It starts with the preparation of molybdenum nanotips by the molding method using the oxidized Si wafer where pyramidal pits are patterned on its surface. The emitters are pyramidal shape with $\sim 1.5 \mu$ m base size and with

the emitter tip apex radius of curvature in the range of 5–10 nm, see Fig. 1(c) inset. On top of the emitter substrate, the extraction gate electrode G_{ext} and the collimation gate electrode G_{col} were fabricated. The gate electrodes were patterned from 0.5 μ m-thick molybdenum layers. The emitter substrate and G_{ext} are separated by a $\sim 1.2 \mu$ m-thick SiO_2 layer, and G_{ext} and G_{col} are separated by a $\sim 1.2 \mu$ m-thick SiON layer. The G_{ext} apertures were patterned by the self-aligned process. A collar structure surrounds the G_{ext} aperture edge, which is height-controllable by adjusting mask-etching and wet-etching duration of the self-aligned G_{ext} aperture patterning step. The G_{col} apertures with 3–5 times larger aperture diameter than that of G_{ext} were patterned by electron beam lithography. On a 7 mm-square chip, six such double-gate single nanotips were fabricated. For the experiment, each chip was mounted on a sample holder, wire-bonded for the gate contacts with Al-wires with

TABLE I. Structural parameters of FE1 and FE2. The lateral offset of the emitter is measured from the center of G_{col} aperture.

	FE1	FE2
G_{ext} aperture diameter (μ m)	1.69	1.43
G_{ext} collar thickness (μ m)	0.25	0.56
G_{col} aperture diameter (μ m)	5.97	6.85
Aperture diameter ratio	3.5	4.8
Emitter lateral offset (μ m)	0	0.8

the diameter of $20\text{ }\mu\text{m}$, and loaded into a measurement chamber equipped with a phosphor screen and a retractable Faraday cup (FC) with a background pressure of $(0.5\text{--}1.5) \times 10^{-8}$ mbar.

The field emission beam was measured as a function of the electron extraction potential V_{ge} and the beam collimation potential V_{col} under DC or pulsed conditions. When a negative collimation potential V_{col} is applied between G_{col} and G_{ext} while generating the field emission beam by applying a positive electron extraction potential V_{ge} between G_{ext} and emitter, see Fig. 1(b), the angular divergence of the beam is substantially reduced. In the case of the DC measurements, we connected G_{ext} to ground potential and applied $-V_{\text{ge}}$ to the emitter substrate and V_{col} (<0) to G_{col} . The DC gate potentials were applied using source-measure units (Keithley 2400) and scanning the voltages with 20 ms steps. For the pulse measurement, we connected G_{col} to ground and applied $-V_{\text{col}}$ to G_{ext} and $(-V_{\text{ge}} + |V_{\text{col}}|)$ to the emitter substrate. The pulsed potential, with a typical duration of $200\text{ }\mu\text{s}$, was generated using a custom-built double-pulsar. The field emission current was measured either directly by inserting the FC in front of the device with a separation of 10 mm or from the integrated beam intensity of the beam images observed on the phosphor screen (calibrated by the current measured with the FC). The beam image was measured with the phosphor screen at the screen potential of 2.5 kV when the device was placed 50 mm from the screen. For the beam measurements, we captured the phosphor screen image generated by pulsed field emission using a synchronously triggered CCD camera with an effective resolution of 16-bit. Care was taken to avoid saturation of all pixel values to be able to evaluate the relative field emission current of the beam as well as the rms radius denoted by dashed white circle in the images in Figs. 3 and 4. The emission current and beam image data presented below were recorded after several hours of conditioning that was done by scanning V_{ge} between 0 and 100 V until the field emission current–voltage characteristics became stable.

III. RESULTS AND DISCUSSION

Figure 2(a) shows the relation between the field emission current I and V_{ge} at zero V_{col} for FE1 and FE2. The observed I – V_{ge} characteristics of the devices above the noise level ($\sim 0.5\text{ nA}$ for the FE1 measurement and $\sim 0.2\text{ nA}$ for the FE2 measurement) were described well by the equation

$$I = A_{\text{FN}}(V_{\text{ge}}/B_{\text{FN}})^2 \exp(-B_{\text{FN}}/V_{\text{ge}}), \quad (1)$$

as shown by the curves in Fig. 2(a). The fitting parameters A_{FN} and B_{FN} were equal to $1.6 \times 10^{-4}\text{ A}$ and 1000 V for FE1, and 2.95 A and 997 V for FE2, respectively. The same B_{FN} values of the two emitters (within $\sim 10\%$ of the estimated uncertainty) indicate the stability of the tip fabrication process since B_{FN} is largely determined by the tip apex radius of curvature R_{tip} ; from the comparison of the observed B_{FN} value and the calculated emission characteristic as a function of R_{tip} ,¹⁶ we found that the estimated R_{tip} are equal

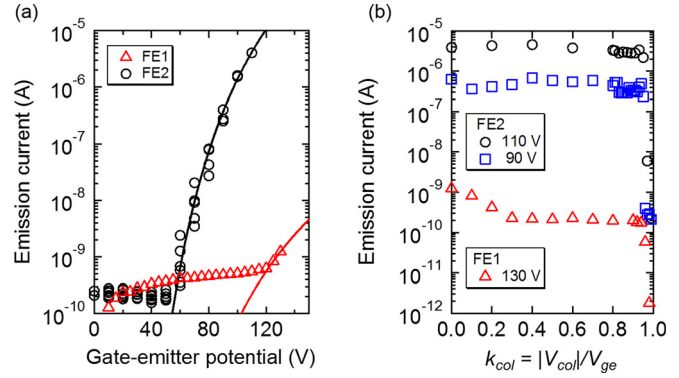


FIG. 2. (Color online) Field emission characteristics of double-gate single nanotip emitters. (a) The relations between the field emission current and V_{ge} at zero collimation potential for FE1 (triangles) and FE2 (circles). Curves are the fitted result of the data above the noise level with the Fowler–Nordheim function. (b) The relations between the field emission current and the collimation potential ratio k_{col} .

to $\sim 10\text{ nm}$ for both devices that is consistent with the high-resolution SEM image of the emitter tip apex [Fig. 1(c), inset].

In Fig. 2(b), we show the field emission current at finite V_{col} . V_{ge} was fixed at 130 V for FE1 (open triangles). For FE2, two sets of measurements with V_{ge} of 90 V (open squares) and 110 V (open circles) are displayed. In Fig. 2(b), we denote V_{col} by the ratio k_{col} defined as

$$k_{\text{col}} \equiv -V_{\text{col}}/V_{\text{ge}}. \quad (2)$$

In the case of FE1, the emission beam current was diminished to 18% of the uncollimated beam current ($k_{\text{col}}=0$) already when k_{col} was equal to 0.3, implying that much of the electric field at the emitter tip apex applied via V_{ge} is relaxed by V_{col} . Increasing k_{col} to 0.94 resulted in the emission current equal to 4.7% of the uncollimated beam current. Further increase of k_{col} to 0.96 results in the decrease of the emission current by several orders of magnitude. In contrast, in the case of FE2, more than 70% of the uncollimated beam current was maintained at k_{col} of 0.94. At the same value, the peak current density was maximum as shown in Fig. 5. We ascribe the improved current conservation characteristic of FE2 to the structural features of gate apertures of the device; compared to those of FE1, the $\sim 400\text{ nm}$ -taller-collar in height, surrounding G_{ext} aperture, together with the $\sim 1\text{ }\mu\text{m}$ -larger- G_{col} aperture diameter provide additional electrostatic shielding of the emitter tip apex by preventing direct line-of-sight from the tip apex from G_{col} aperture, and reducing the influence of V_{col} on the emission current.

Figure 3 presents the selected field emission beam images of FE1 for k_{col} between 0 and 0.98 when V_{ge} was equal to 143 V. The uncollimated beam with zero k_{col} showed two separated spots with different beam intensities. Interestingly, as we increased k_{col} , the two spots converged as indicated by the shrinking beam envelopes denoted by the broken circles toward point C, given by the crossing of the horizontal and vertical broken lines. This suggests that only a part of the emitter apex within the radius of R_{tip} is active, but G_{col} can collimate the beam emitted from the whole apex. When k_{col}

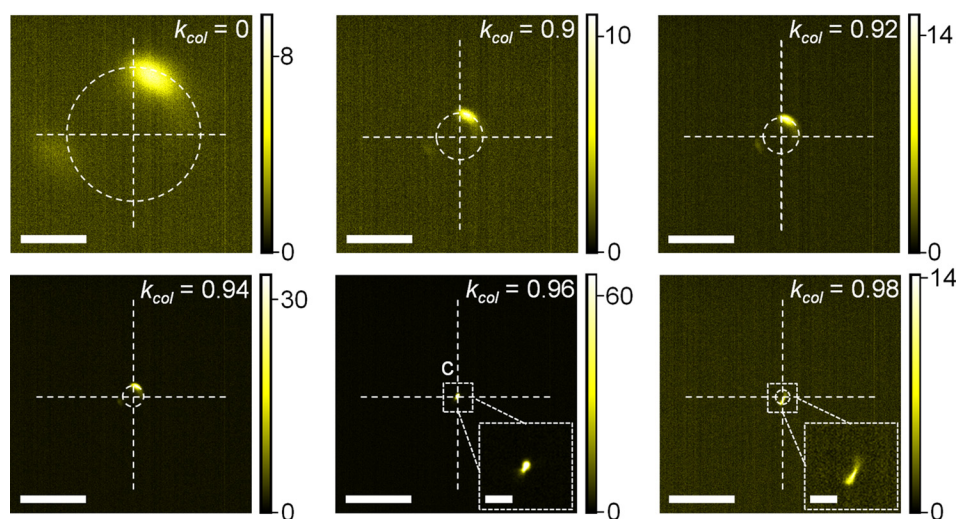


FIG. 3. (Color online) Variation of the field emission beam of FE1 with the increase of k_{col} from 0 to 0.98 for V_{ge} of 143 V. The scale bar of the images is 5 mm. The inset images are enlarged to highlight the small beam spot (the scale bar is 1 mm.).

was equal to 0.96, the two spots became indistinguishable at point C and the peak beam intensity was enhanced by a factor of ~ 7 from the uncollimated beam with k_{col} of 0. Further increase of k_{col} to 0.98 substantially reduced the emission current and beam intensity. The comparison of the two beams with k_{col} equal to 0.96 and 0.98 suggests the over-focusing of the beam at k_{col} of 0.98.

Figure 4 shows the field emission beam of FE2 at various k_{col} for V_{ge} equal to 90 V. Differently from FE1, the zero k_{col} field emission beam of FE2 spreads more uniformly over the area with the diameter of ~ 5 mm, thereby indicating that much larger fraction of the emitter tip apex within R_{tip} contributes to the field emission. When we increased k_{col} from 0 to 0.8, the beam size reduced only gradually by $\sim 25\%$. Then further increase of k_{col} to 0.94 resulted in the steep reduction of the beam by a factor of 10 with the simultaneous increase of the peak beam intensity by a factor of ~ 6 , see Fig. 5. A similar beam collimation was also observed with the high

current beam at V_{ge} of 110 V. These observations demonstrate the excellent beam collimation characteristic of these double-gate single nanotip emitters.¹⁷

In Fig. 6, we summarized the relation between the beam radius and k_{col} . From the rms beam radius R , we evaluated the rms transverse velocity u_t with the assumption of free propagation of the electrons in the transverse direction while they are accelerated along the beam axis, see Ref. 8. In short, u_t is equal to $\sim R/T$, where T is the propagation time of the electron from the emitter to the screen. T is approximately equal to $2L/u_{scr}$, where L is the emitter-screen distance equal to 50 mm and u_{scr} is the velocity equal to $\sqrt{2eV_{scr}/m_e}$ (V_{scr} is the screen potential equal to 2.5 kV, e is the electron charge, and m_e is the electron rest mass). Figure 6 shows an order of magnitude reduction of u_t with the increase of k_{col} from zero to 0.94 (FE1 case) or 0.95 (FE2 case) with the smallest value compatible with the array beam experiment.^{8,18}

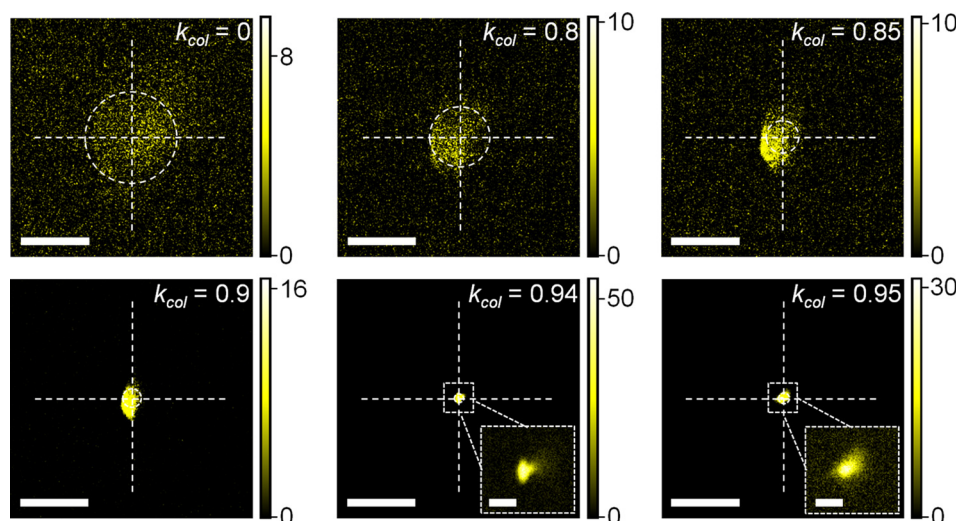


FIG. 4. (Color online) Variation of the field emission beam of FE2 with the increase of k_{col} from 0 to 0.95 for V_{ge} of 90 V. The scale bar of the images is 5 mm. The inset images are enlarged to highlight the small beam spot (the scale bar is 1 mm.).

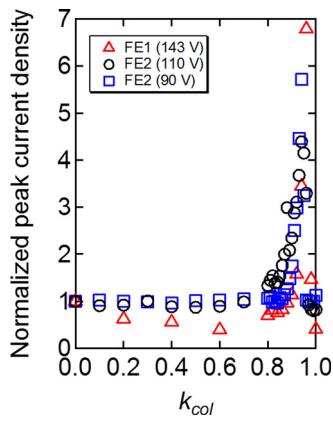


FIG. 5. (Color online) Peak current density of the field emission beams as a function of k_{col} . The current density values were normalized by the zero k_{col} value of each scan.

As the beam images in Fig. 6 show, we found that R and u_t of FE2 beam at k_{col} of 0.94 increased by a factor 3 when V_{ge} was increased from 90 to 110 V with the concomitant increase of the emission current from ~ 50 nA to ~ 0.5 μ A. This effect is likely caused by the Coulomb repulsion of the electrons. In the case of the uncollimated beam, the large beam divergence at the source (on the order of 30°) quickly dilutes the density of electrons as they propagate to the anode (screen), and the beam radius on the screen is unchanged within 20% as the current increases from ~ 100 nA to ~ 4 μ A. However, such a dilution does not occur in the case of the highly collimated beam with k_{col} of ~ 1 because of the order of magnitude smaller initial angular spread. Therefore, the initial diameter of the beam (equal to at most the diameter of the G_{col}

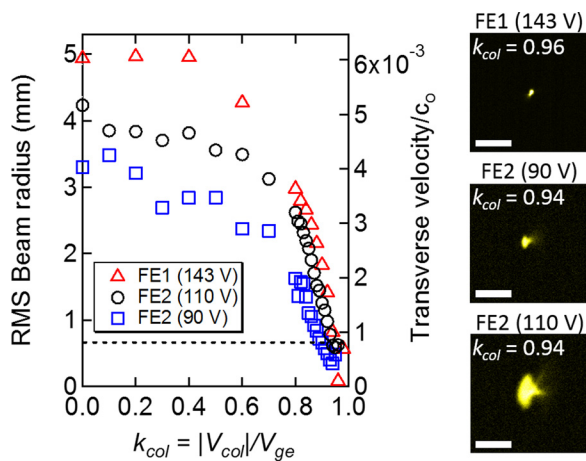


FIG. 6. (Color online) Variation of the rms radius of the beam envelope and transverse velocity u_t normalized by the light velocity in vacuum c_0 with the increase of k_{col} from 0 to ~ 1 . For each scan, V_{col} was varied while V_{ge} was fixed at certain value; for FE1 V_{ge} was equal to 143 V (red triangle), and for FE2, V_{ge} was equal to 90 V (blue squares) and 110 V (black circles). The broken line shows the transverse velocity equal to $8 \times 10^{-4} c_0$, corresponding to the performance of the state-of-the-art photocathode with intrinsic beam emittance of 0.2 mm mrad for a 1 mm-diameter cathode currently in use. The maximally collimated beams of each scans are also shown. The scale bar of the images corresponds to 2 mm.

aperture) at a few micron above the G_{col} plane can be maintained on the screen only when the beam current density is small or when the acceleration field is sufficiently large so that the longitudinal velocity is increased quickly before the space-charge expansion of the beam increases u_t and degrades the beam brilliance. In fact, previous simulation showed that the acceleration field of 10–100 MV/m (typically used for electron guns) is sufficient to maintain the low emittance of field emission beamlet with the tip current of 1–10 μ A.¹⁹ In contrast, the acceleration field of the present experiment was ~ 50 kV/m and not sufficient to maintain the small initial emittance of the space-charge dominated beam, resulting in a larger beam size as observed in Fig. 6. We do not consider that the expanded beam radius at the higher V_{ge} is due to the nonlinearity of the focusing characteristic of G_{col} at higher V_{ge} . In fact, observation that the FE1 beam at V_{ge} of 143 V (with ~ 0.1 nA emission current) shown in Fig. 6 is even smaller than the FE2 beam with V_{ge} of 90 V indicates that such nonlinearity of the G_{col} can be small. Nevertheless, u_t of the FE2 beam at V_{ge} of 110 V and at k_{col} of 0.94 was small; the value equal to $\sim 0.7 \times 10^{-3} c$ (c is the light velocity in vacuum) is smaller than the state-of-the-art photocathodes (with intrinsic beam emittance of 0.2 mm mrad for a 1 mm-diameter cathode) currently in use.²⁰ We also note that the emitter position of FE2 is shifted from the G_{col} center by ~ 0.8 μ m caused by misalignment during the electron beam lithography process. Therefore, improved single nanotip emitter performance is expected with a smaller offset of the emitter position to realize a further reduction of the minimum beam size and further enhancement of beam current density.

Finally, we discuss the difference of the field emission current of the two emitters at zero k_{col} (i.e., 1.24 nA for FE1 at V_{ge} of 130 V and 4.04 μ A for FE2 at V_{ge} of 110 V). Considering the fact that B_{FN} of the two devices are approximately the same, the lower current and lower A_{FN} value of FE1 than those of FE2 is most likely ascribed to the difference of the effective emitting area S . From the Fowler–Nordheim equation, we can relate the value of A_{FN} with S using the following approximate relationship (see Ref. 21):

$$A_{\text{FN}} \approx Sab^2\Phi^2 \exp(bc^2/\Phi^{0.5}), \quad (3)$$

where the constants a , b , and c are given by $a = 1.541434 \times 10^{-6} \text{ A eV V}^{-2}$, $b = 6.830890 \text{ eV}^{-3/2} \text{ V nm}^{-1}$, and $c = 1.199985 \text{ eV V}^{-1/2} \text{ nm}^{1/2}$, and Φ is the work function of Mo equal to 4.5 eV.^{21,22} Substituting πR_{tip}^2 for S , A_{FN} takes the value equal to 0.2–20 A for R_{tip} in the range of 1–10 nm. This is in good agreement with $A_{\text{FN}} (= 2.95 \text{ A})$ of FE2, obtained from the fitting of the I – V , Fig. 2. Accordingly, the small A_{FN} of FE1 indicates that the emission area of the FE1 beam is much smaller than the emitter tip apex. This interpretation is compatible with the highly nonuniform beam image of FE1 (Fig. 3) with the indication that the active emission part of FE1 is limited to two separate small spots, perhaps occupying a small fraction of $\sim 10^{-2}$ or

lower at the tip apex. The numerical disagreement of the actual emission area and the value estimated from the Fowler–Nordheim fitting has been discussed previously.²² However, further quantitative comparison will require atomically resolved beam image measurement, resolving the work function nonuniformity as well as more involved theory that takes into account the precise expression of the field emission current density;²¹ therefore, it is out of the scope of the present manuscript.

IV. SUMMARY AND CONCLUSIONS

In summary, we have studied the field emission beam characteristics of double-gate single metal nanotips with G_{ext} and G_{col} electrodes. A possibility to produce highly collimated electron beamlet with the proposed double-gate structure, which was shown previously by array emitters, was demonstrated with single tip emitter in this work. The importance of the electrostatic shielding of the tip apex from the collimation potential, previously discussed with the array experiment, was confirmed using well defined single tip operation. We conclude that an excellent collimation capability with minimal current loss can be attained with double-gate single nanotip emitters, optimized in terms of the G_{ext} aperture shape and the alignment of G_{col} aperture. In addition, the single tip experiment here showed that one can produce the highly collimated beamlet with the emission current on the order of $1\ \mu\text{A}$, which suggests that one can produce highly collimated field emission beam from double-gate FEA with the emission current in the order of tens of milliamperes with the intrinsic emittance below $\sim 0.1\ \text{mm mrad}$ and that nanotips are highly promising for high brilliance applications such as time resolved electron diffraction studies to provide atomic views of structural dynamics.

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